

Germanium and Tin Precursors for Chalcogenide Materials Containing *N*-Alkoxy Thioamide Ligands

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Cite This: *ACS Omega* 2024, 9, 28707–28714



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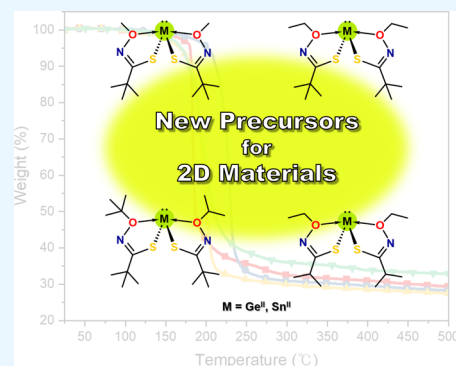
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ABSTRACT: This study describes the synthesis of germanium and tin complexes $\text{Ge}(\text{mdpaS})_2$ (1), $\text{Ge}(\text{edpaS})_2$ (2), $\text{Ge}(\text{bdpaS})_2$ (3), $\text{Ge}(\text{empaS})_2$ (4), $\text{Sn}(\text{mdpaS})_2$ (5), $\text{Sn}(\text{edpaS})_2$ (6), $\text{Sn}(\text{bdpaS})_2$ (7), and $\text{Sn}(\text{empaS})_2$ (8) (mdpaSH = (*Z*)-*N*-methoxy-2,2-dimethylpropanimidothioic acid; edpaSH = (*Z*)-*N*-ethoxy-2,2-dimethylpropanimidothioic acid; bdpaSH = (*Z*)-*N*-(tert-butoxy)-2,2-dimethylpropanimidothioic acid; empaSH = (*Z*)-*N*-ethoxy-2-methylpropanimidothioic acid), using newly designed *N*-alkoxy thioamide ligands as precursors for metal chalcogenide materials. All complexes were characterized using various analytical techniques, and the single-crystal structures of complexes 5 and 7 revealed a distorted seesaw geometry in the monomeric SnL_2 form. Thermogravimetric (TG) curves showed differences between Ge compounds, which exhibited single-step weight losses, and Sn compounds, which exhibited multistep weight losses. As a result, we suggest that the synthesized complexes 1–8 are potential precursors for group IV metal chalcogenide materials.



INTRODUCTION

In the modern electronics industry, layered materials are attractive components because they can be applied in a variety of optical fields such as transistors, photodetectors, ultrafast lasers, touch panels, and optical modulators.^{1–4} Among layered materials, two-dimensional (2D) materials are very suitable for various electronic device fields because they have excellent electron mobility and a large surface area compared to zero-dimensional or one-dimensional materials.^{5,6} Graphene is a representative 2D material; however, it has no band gap and weak light absorption, so its application in the optoelectronic field is limited; therefore, interest in the exploration of new layered materials is increasing.^{7–12} Among many other 2D materials, tin and germanium monochalcogenide materials¹³ (GeS ,¹⁴ GeSe ,¹⁵ SnS ,^{16–18} and SnSe ^{19,20}) have been discovered to have anisotropic structure, and they have recently gained attention and popularity in the semiconductor field due to their anisotropic electronic/optical properties, high absorption coefficient, high thermal stability, high oxidation resistance, structural stability, suitable band gap, and photoluminescence.²¹ In addition, they are environmentally friendly, economical, and have low toxicity, making them attractive alternatives to toxic lead chalcogenides.^{22,23}

GeS is a p-type semiconductor that is stacked together through van der Waals interactions and has a direct band gap of 1.65 eV²⁴ in the bulk visible region. In a single layer, it has an indirect band gap of 2.34 eV and an electron mobility of 3680 $\text{cm}^2/(\text{V s})$.²⁵ Although GeS has not been studied in detail so far, it is a promising candidate material for batteries,^{23,26,27}

photovoltaics (PV), and light sensing owing to its excellent photosensitivity, convenient band gap in the visible region, and strong absorption over a wide spectral range and conductivity.^{28,29}

SnS is essentially a p-type semiconductor^{30,31} with a band gap of 0.9–1.8 eV,³² a high absorption coefficient of over 10^4 cm^{-1} ,³³ a hole density of 10^{15} – 10^{18} cm^{-3} , and a high mobility of $\sim 90 \text{ cm}^2/(\text{V s})$. These properties make SnS a potential candidate for the development of low-cost thin-film solar cell absorbers³⁴ and sustainable photovoltaic (PV) absorbers.^{35,36}

Various methods have been employed to form high-quality GeS and SnS materials, including sol–gel processes, solid-state reactions, solution processes, laser photolysis, electrodeposition, chemical vapor decomposition (CVD), and atomic layer deposition (ALD).^{16,37–43}

In addition, single-source precursors provide several advantages: much easier handling, high atom efficiency, better homogeneity, and a simple delivery system with properties such as stoichiometry, morphology, and area selectivity of the target material as directly controlled in the precursor.^{44–46} In the case of SnS , some precursors were examined as single sources without an H_2S reagent, such as Bz_3SnCl (saltscz)

Received: March 29, 2024

Revised: June 5, 2024

Accepted: June 7, 2024

Published: June 20, 2024



(saltscz = thiosemicarbazone of salicylaldehyde), $Bz_3SnCl(4\text{-}clbenzscz)$ (4-clbenzscz = thiosemicarbamidocarbazone of 4-chlorobenzaldehyde),⁴⁷ $Sn(^nBu)_2[S_2CN(RR')]_2$ ($R, R' = Et$; $R = Me$ and $R' = ^nBu$; $R, R' = ^nBu$; $R = Me$ and $R' = nHex$),⁴⁸ bis[2-methyl-*N*-(1-methylethyl)-propanethioamide]tin(II), bis[*N*-(1,1-dimethylethyl)-2-methylpropanethioamide]tin(II),⁴⁹ (dimethylamido)(*N*-phenyl-*N,N'*-dimethylthioureate)-tin(II) dimer,⁵⁰ and $\{CyNC(NMe_2)NCy\}\text{-SnS}$.⁵¹

However, because only an extremely small number of single-source precursors for GeS materials have been previously reported, germanium chalcogenide materials are usually obtained from separate sources, such as germanium, germanium halides, and alkyl germanium with sulfur reagents.^{26,44}

Therefore, we focused on developing new single-source precursors for germanium and tin sulfide materials, and synthesized newly designed organic ligands containing sulfur atoms, such as mdpaSH, edpaSH, bdpaSH, and empasH, using previously reported ligands.^{52,53}

Herein, we report the synthesis of new Ge and Sn complexes for use as chalcogenide materials and thin films as single-source precursors. Each molecule of the designed homoleptic compounds has one metal atom and two bidentate ligands containing two sulfur atoms. These complexes are designated as $Ge(mdpaS)_2$ (**1**), $Ge(edpaS)_2$ (**2**), $Ge(bdpaS)_2$ (**3**), $Ge(empasS)_2$ (**4**), $Sn(mdpaS)_2$ (**5**), $Sn(edpaS)_2$ (**6**), $Sn(bdpaS)_2$ (**7**), and $Sn(empasS)_2$ (**8**). Complexes **1–8** were characterized using nuclear magnetic resonance (NMR) spectroscopy, Fourier-transform infrared (FT-IR) spectroscopy, thermogravimetric analysis (TGA), and elemental analysis (EA). Complexes **5** and **7** were further characterized using single-crystal X-ray crystallography (SC-XRC).

RESULTS AND DISCUSSION

We designed a series of new ligands, *N*-alkoxy thioamides, which were synthesized by substituting an oxygen atom in previously reported *N*-alkoxy carboxamide ligands with a thiol group. The reaction between *NH*-form ligands (mdpaH, edpaH, bdpaH, and empasH)⁵² and 0.25 equiv of P_2S_5 afforded the desired SH-form ligands (mdpaSH, edpaSH, bdpaSH, and empasH) in moderate yields of 48–72% (Scheme 1).

Scheme 1. Synthetic Scheme of a Series of *N*-Alkoxy Thioamide Ligands



The four newly synthesized ligands were characterized using physicochemical analysis and reacted to obtain the desired Ge and Sn complexes. All of the complexes in this study were successfully synthesized via an acid–base reaction with germanium or tin bis(trimethylsilyl)amide and the respective *N*-alkoxy thioamide ligands in a ratio of 1:2, as shown in Scheme 2.

Complexes **1–8** were obtained as white powders by recrystallization and further purified under each condition, as described in the Experimental Section.

The 1H NMR spectra demonstrated that all peaks of **1–8** were fully shifted relative to the respective corresponding free ligands. The SH peak and btsa peak in the complexes **1–8** were noticeably absent.⁵⁴ Compound **1** showed two singlets at $\delta_H = 1.33$ (18H, *tert*-butyl group) and 3.85 (6H, *O*-methyl group) ppm. The 1H NMR spectrum of **2** displayed one triplet at $\delta_H = 1.33$ (6H, CH_3 of *O*-ethyl group) ppm, one singlet at $\delta_H = 1.37$ (18H, *tert*-butyl group) ppm, and a quartet at $\delta_H = 4.23$ (4H, CH_2 of *O*-ethyl group) ppm. The spectrum of **3** exhibited only the *tert*-butyl group as two singlets of 18H at $\delta_H = 1.39$ and 1.47 ppm. The spectrum for complex **4** contains one doublet at $\delta_H = 1.26$ (12H, CH_3 of isopropyl group) ppm, one triplet at $\delta_H = 1.30$ (6H, CH_3 of *O*-ethyl group) ppm, one septet at $\delta_H = 2.84$ (2H, *CH* of isopropyl group) ppm, and one quartet at $\delta_H = 4.23$ (4H, CH_2 of *O*-ethyl group) ppm. Likewise, 1H NMR spectra of tin complexes **5–8** containing the corresponding ligands showed the same patterns as the germanium complexes. (Figures S1–S16).

Additionally, the S–H stretching frequency of free ligands and the Si– CH_3 rocking vibration from bis(trimethylsilyl)-amide disappeared in the FT-IR spectra of the germanium and tin products. On the other hand, the C–H stretching from alkane groups was exhibited in the range of $\nu = 2963\text{--}3109\text{ cm}^{-1}$.⁵⁵

To investigate the molecular structure of the solid-phase conformer using X-ray crystallography (XRC), single crystals were grown in a saturated toluene solution at room temperature in an Ar-filled glovebox. Complexes **5** and **7** have a triclinic crystal system in the space group *P*-1 and exist as monomers with two molecules in each unit cell.

The crystal structures of **5** and **7** reveal a distorted seesaw geometry with one Sn atom bonded to two respective corresponding ligands such as mdpaS (**5**) and bdpaS (**7**), and they form two $\kappa^2\text{-O,S}$ -chelating structures with five-membered ring metallacycles, as shown in Figures 1 and 2. The lone pair of Sn (II) atoms is located at one equatorial position, similar to the trigonal bipyramidal geometry, and repulsion from the lone pair results in a butterfly shape. The two O atoms, O1 and O2, in each ligand occupy the axial position, whereas the two S atoms (S1 and S2) are located in the equatorial plane with a lone pair.

In the case of complex **5**, the bond distance Sn–S1 is 2.5368(11) Å and Sn–S2 is 2.5345(10) Å. The O1–Sn–O2 axial angle and S1–Sn–S2 equatorial angle with mdpaS ligands were found to be 143.45(9) and 97.03(4)°, respectively, and the bite angles are 71.76(7)° (S1–Sn–O1) and 71.41(7)° (S2–Sn–O2). For **7**, the Sn–S1 bond distance is 2.5161(4) Å, and Sn–S2 is 2.5455(4) Å. The axial direction O1–Sn–O2 has an angle of 146.95(3)°, and that in the equatorial direction is 95.574(15)°. The bite angles for the bdpaS ligands are 72.98(3)° and 70.63(3). These results demonstrate that the respective bond distances of Sn–S are within the range of reported distance (2.510–2.822 Å),⁵⁶ and compound **7**, which has two bdpaS ligands containing a *tert*-butyl group, has a more clearly tilted structure than that of **5**. The reason for the differences in the distances or angles, even within a series of similar ligands, could be the replacement of relatively sterically compact functional groups, such as methyl, by bulkier *tert*-butyl groups of the bdpaS ligand (Table 1).

Scheme 2. Synthetic Scheme of Complexes 1–8

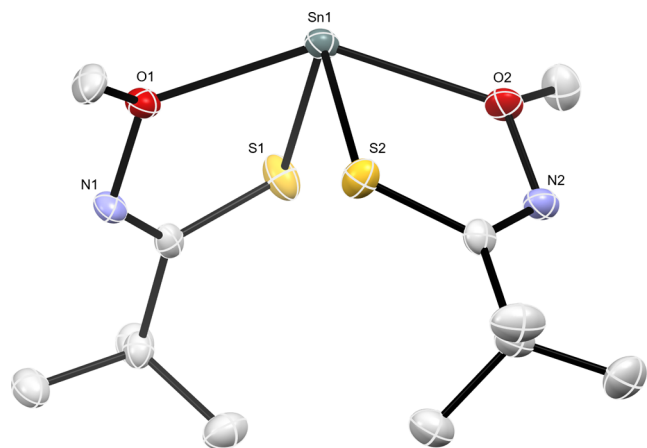
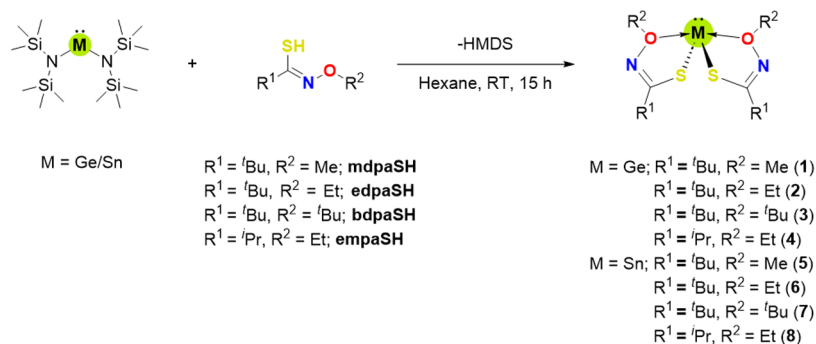


Figure 1. Molecular structure of complex 5. All hydrogen atoms are omitted for clarity (green, tin; red, oxygen; blue, nitrogen; gray, carbon).

The melting points of complexes 3 and 7, which contain the *tert*-butyl group, were relatively high compared to those of compounds 4 and 8, which contain the empaS ligand. Among them, the melting points of the germanium complexes 1–3 are 165, 129, and 194 °C, respectively, which are higher than those of the tin complexes 5–7, 90, 61, and 98 °C, respectively.

Thermogravimetric (TG) analysis of all complexes was performed from 30 to 500 °C at a heating rate of 20 K/min. Germanium complexes 1–4 showed single-step TG curves. The weight loss of each compound started at 139, 156, 125, and 138 °C, respectively. Among these, 2 showed the highest thermal stability as shown by the high decomposition temperature, and 3 had the lowest residue of 27% with the nonvolatile residue measured at 500 °C. In contrast, tin complexes 5–8 exhibited multistep weight loss. The 1% onset temperatures were confirmed at 126, 114, 127, and 126 °C, respectively, and the lowest amount of nonvolatile residue at 500 °C was 34% in the case of compound 7. The residues of all of the complexes depended on the type of ligand. Compounds 4 and 8 with the empaS ligand showed the highest residual weight, followed by 1 and 5 with mdpaS, 2 and 6 with edpaS, and 3 and 7 with bdpaS ligands, which showed the lowest residual weight.

The differential scanning calorimetry (DSC) diagrams of the complexes feature an endothermic peak at 160 (1), 130 (2), 199 (3), 88 (4), 92 (5), 61 (6), 102 (7), 80 (8) °C, and this is attributed to the differences in melting point of each corresponding compound. In addition, the exothermic peak can be regarded as the decomposition temperature of the

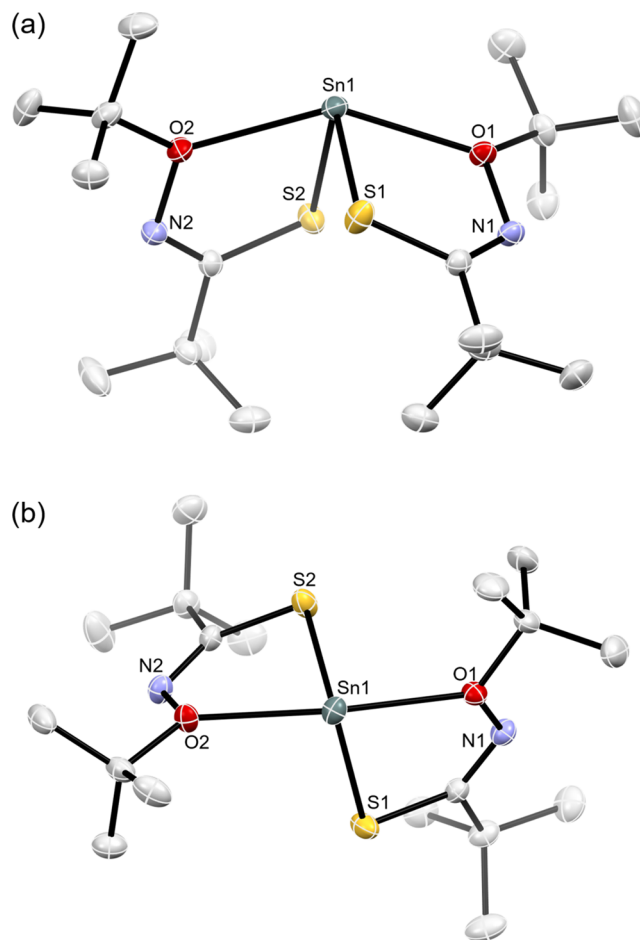


Figure 2. (a) Side view and (b) top view of molecular structure of complex 7. All hydrogen atoms are omitted for clarity (green, tin; red, oxygen; blue, nitrogen; gray, carbon).

specific materials, as seen in their TGA behavior (Figures 3 and 4, Table 2).

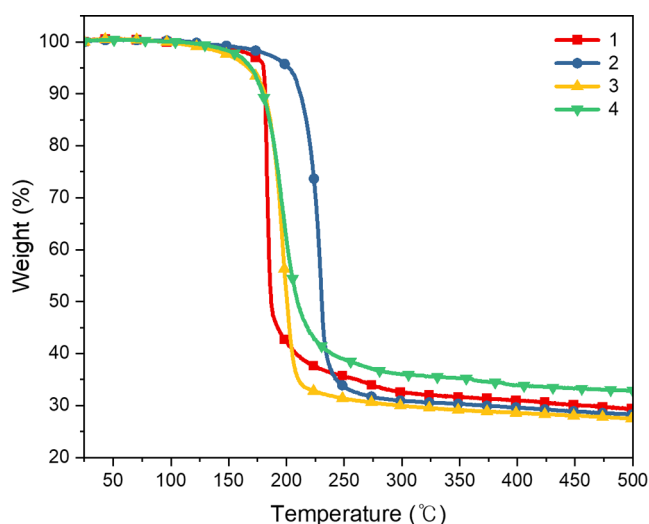
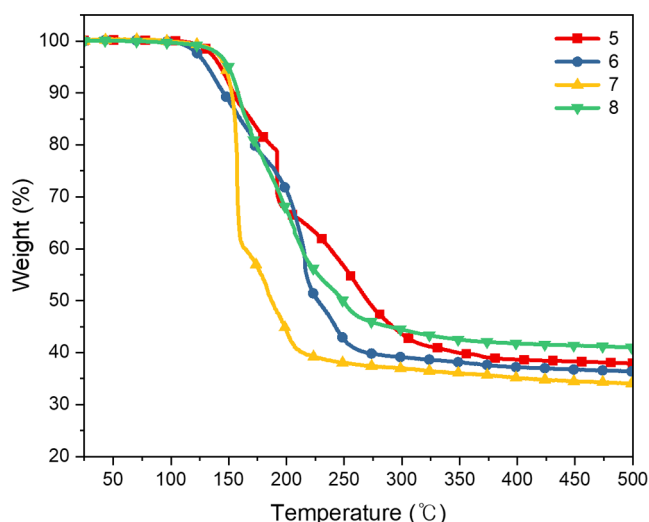
EXPERIMENTAL SECTION

General Remarks. ^1H and $^{13}\text{C}\{1\text{H}\}$ NMR spectra were recorded using Bruker 400 and 500 MHz spectrometers with benzene- d_6 as the solvent and reference. FT-IR spectra were collected in the range 4000–400 cm^{-1} using a Nicolet Nexus FT-IR spectrophotometer with a 4 mm KBr window of KBr pellets. The melting points of the samples were measured using closed-ended capillaries in an electrothermal melting point apparatus, and were not corrected. The TGA was conducted at

Table 1. Selected Bond Lengths (Å) and Bond Angles (deg) for Complex 5 and 7

Bond Length (Å)	Complex	
	5	7
Sn–O1	2.377(3)	2.4001(10)
Sn–O2	2.415(3)	2.4830(11)
Sn–S1	2.5368(11)	2.5161(4)
Sn–S2	2.5345(10)	2.5455(4)

Bond Angles (deg)	Complex	
	5	7
O1–Sn–S1	71.76(7)	72.98(3)
O1–Sn–S2	83.71(7)	83.37(3)
O2–Sn–S1	84.87(7)	89.21(3)
O2–Sn–S2	71.41(7)	70.63(3)
O1–Sn–O2	143.45(9)	146.95(3)
S1–Sn–S2	97.03(4)	95.574(15)

**Figure 3.** TGA curves of germanium complexes 1–4.**Figure 4.** TGA curves of tin complexes 5–8.

a scan rate of 20 K/min using a NETZSCH TG 209 F3TG instrument under N₂ gas in a glovebox. EA was performed using a Thermo Scientific Flash 2000 organic elemental analyzer. Commercial chemicals were purchased from Aldrich,

TCI, Alfa Aesar, or STREM without further purification. All solvents were purified using an Innovative Technology PSMD-4 solvent purification system, and all reactions were performed under inert, dry conditions in an Ar-filled glovebox. Ge(II) and Sn(II) amides, Sn[N(SiMe₃)₂]₂ and Ge[N(SiMe₃)₂]₂, were prepared according to literature procedures.^{37,38} The applied *N*-alkoxy carboxamide ligands, mdpaH, edpaH, and empah, were prepared according to ref 52. The bdpaH ligand was synthesized following the same procedure, with *O*-*tert*-butylhydroxylamine hydrochloride used as a reagent to substitute the chlorine.

General Procedure for Synthesis of *N*-Alkoxy Thioamide Ligands. P₂S₅ (0.25 equiv) was slowly added to a diethyl ether solution containing the *N*-alkoxy carboxamide ligands mdpaH, edpaH, bdpaH, or empah. The reaction mixture was stirred under inert conditions in an Ar-filled glovebox at room temperature. A white powder was gradually produced with constant stirring. After 3 h, the mixture was filtered to remove the solids, and the filter cake was washed three times with diethyl ether. The solvent was evaporated *in vacuo* using a pump at a pressure of approximately 120 Torr. Subsequently, the crude product was purified by distillation at 40 °C and collected in a cooling bath containing dry ice and ethanol to obtain the desired product as a colorless liquid. The synthesized ligands are very volatile and unstable at high temperatures. So, we purified the ligands in the conditions of low temperatures of 35–40 °C under 3 Torr, with a cooling bath to prevent the decomposition of ligands.

Synthetic Procedures. mdpaSH. mdpaH (10 g, 97.0 mmol) was used. Yield: 7.3 g (63%). ¹H NMR (500 MHz, C₆D₆) δ (ppm): 4.72 (s, 1H), 3.72 (s, 3H), 1.15 (s, 9H). ¹³C NMR (126 MHz, C₆D₆) δ (ppm): 157.67, 61.50, 38.80, 28.82. FT-IR (KBr, cm⁻¹): 2968 (s), 2937 (m), 2901 (m), 2869 (w), 2817 (w), 2576 (w), 1741 (w), 1573 (m), 1477 (m), 1460 (m), 1394 (w), 1365 (m), 1242 (w), 1205 (w), 1086 (s), 1069 (m), 1036 (s), 1008 (s), 900 (m), 862 (w), 765 (m), 675 (w), 545 (m).

edpaSH. edpaH (10 g, 68.9 mmol) was used. Yield: 8.0 g (72%). ¹H NMR (400 MHz, C₆D₆) δ (ppm): 4.79 (s, 1H), 4.07 (q, *J* = 7.0 Hz, 2H), 1.16 (s, 8H), 1.10 (t, *J* = 7.1 Hz, 3H). ¹³C NMR (126 MHz, C₆D₆) δ (ppm): 157.21, 157.20, 69.65, 38.88, 28.90, 14.73. FT-IR (KBr, cm⁻¹): 2970 (m), 2933 (m), 2900 (w), 2576 (w), 1575 (m), 1478 (m), 1461 (m), 1384 (m), 1365 (m), 1137 (w), 1092 (m), 1071 (m), 1037 (s), 1019 (s), 952 (s), 924 (s), 879 (w), 863 (w), 799 (w), 786 (w), 665 (w), 557 (w).

bdpaSH. bdpaH (10 g, 57.7 mmol) was used. Yield: 6.1 g (56%). ¹H NMR (500 MHz, C₆D₆) δ (ppm): 4.80 (s, 1H), 1.24 (s, 9H), 1.15 (s, 9H). ¹³C NMR (101 MHz, C₆D₆) δ (ppm): 155.68, 79.44, 39.16, 28.98, 27.83. FT-IR (KBr, cm⁻¹): 2971 (s), 2932 (m), 2870 (w), 2573 (w), 1579 (m), 1476 (m), 1460 (m), 1386 (w), 1364 (s), 1238 (w), 1192 (s), 1072 (m), 1027 (m), 948 (s), 919 (s), 885 (m), 802 (m), 657 (w), 552 (m).

empahSH. empah (10 g, 76.2 mmol) was used. Yield: 5.4 g (48%). ¹H NMR (400 MHz, C₆D₆) δ (ppm): 4.24 (s, 1H), 4.09 (q, *J* = 7.0 Hz, 2H), 2.52 (hept, *J* = 6.9 Hz, 1H), 1.11 (t, *J* = 7.0 Hz, 3H), 1.04 (d, *J* = 6.9 Hz, 6H). ¹³C NMR (101 MHz, C₆D₆) δ (ppm): 154.54, 69.65, 36.12, 20.91, 14.74. FT-IR (KBr, cm⁻¹): 2968 (s), 2935 (m), 2879 (m), 2575 (w), 1650 (s), 1522 (m), 1471 (w), 1455 (w), 1383 (m), 1238 (m), 1154 (w), 1120 (m), 1099 (m), 1048 (s), 1016 (m), 948 (m), 882 (m), 851 (w), 684 (m), 647 (m), 560 (m).

Table 2. Thermal Physical Profiles of Complexes 1–8

Complex	Molecular Weight (g/mol)	Melting Point (°C)	Temperature at 1 wt % Loss (°C)	Temperature at 50 wt % Loss (°C)	Residual Mass (%)
1	365.09	165	139	187	29.4
2	393.14	129	156	231	28.2
3	449.25	194	125	200	27.5
4	365.09	86	138	210	32.8
5	411.17	90	127	249	37.9
6	439.22	61	114	227	36.4
7	495.33	98	128	187	34.0
8	411.17	85	126	270	41.0

General Procedure for Synthesis of Ge or Sn(*N*-alkoxy thioamide)₂. A hexane solution of *N*-alkoxy thioamide ligands (2 equiv), mdpaSH, edpaSH, bdpaSH, or empasH was added dropwise to a hexane solution containing Ge(btsa)₂ or Sn(btsa)₂ (1 equiv). The reaction mixture was stirred continuously at room temperature in an Ar-filled glovebox for 15 h. Subsequently, the volatiles were evaporated *in vacuo*, and the crude pale yellow product was purified by recrystallization or sublimation to obtain the desired product as a white powder. X-ray-quality single crystals were grown from a saturated solution in toluene at room temperature in an Ar-filled glovebox by slow evaporation of the solvent.

Synthetic Procedures. **Ge(mdpaS)₂ (1).** mdpaSH (0.74 g, 5.0 mmol) was used for *N*-alkoxy thioamide ligand. The product was obtained by sublimation (140 °C, 0.3 Torr). Yield: 0.78 g (86%). M.P.: 165 °C. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 3.85 (s, 6H), 1.33 (s, 18H). ¹³C NMR (101 MHz, C₆D₆) δ (ppm): 158.0, 61.7, 40.1, 29.0. Anal. Found (Calcd for C₁₂H₂₄N₂O₂S₂Ge): C, 39.16 (39.48); H, 6.58 (6.63); N, 7.62 (7.67); S, 17.59 (17.57). FT-IR (KBr, cm⁻¹): 2981 (s), 2968 (s), 2937 (s), 2898 (m), 2865 (m), 2818 (w), 1568 (m), 1475 (m), 1456 (m), 1391 (w), 1362 (m), 1255 (w), 1068 (s), 1031 (s), 982 (s), 894 (m), 844 (w), 800 (m), 687 (m), 548 (w).

Ge(edpaS)₂ (2). edpaSH (0.81 g, 5.0 mmol) was used for *N*-alkoxy thioamide ligand. The product was obtained by sublimation (100 °C, 0.3 Torr). Yield: 0.9 g (92%). M.P.: 129 °C. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 4.23 (q, *J* = 7.0 Hz, 4H), 1.37 (s, 18H), 1.31 (t, *J* = 7.0 Hz, 6H). ¹³C NMR (101 MHz, C₆D₆) δ (ppm): 157.1, 70.4, 40.3, 29.1, 15.2. Anal. Found (Calcd for C₁₄H₂₈N₂O₂S₂Ge): C, 42.51 (42.77); H, 6.92 (7.18); N, 7.02 (7.13); S, 16.25 (16.31). FT-IR (KBr, cm⁻¹): 2970 (s), 2943 (m), 2928 (m), 2897 (w), 2868 (w), 1574 (m), 1474 (m), 1456 (m), 1440 (w), 1394 (w), 1377 (m), 1363 (m), 1091 (m), 1067 (s), 1033 (s), 994 (s), 936 (s), 925 (s), 873 (w), 789 (w) 691 (w).

Ge(bdpaS)₂ (3). bdpaSH (0.95 g, 5.0 mmol) was used for *N*-alkoxy thioamide ligand. The product was obtained by sublimation (90 °C, 0.3 Torr). Yield: 1.04 g (93%). M.P.: 194 °C. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 1.47 (s, 9H), 1.39 (s, 9H). ¹³C NMR (126 MHz, C₆D₆) δ (ppm): 152.4, 82.7, 41.1, 29.3, 28.4. Anal. Found (Calcd for C₁₈H₃₆N₂O₂S₂Ge): C, 47.95 (48.12); H, 8.19 (8.08); N, 6.08 (6.24); S, 14.55 (14.27). FT-IR (KBr, cm⁻¹): 2971 (s), 2928 (s), 2902 (m), 2866 (m), 1590 (m), 1474 (m), 1456 (m), 1389 (m), 1364 (s), 1264 (w), 1250 (w), 1188 (s), 1047 (m), 1010 (s), 951 (s), 916 (m), 873 (m), 861 (s), 806 (w), 765 (m).

Ge(empas)₂ (4). empasH (0.74 g, 5.0 mmol) was used for *N*-alkoxy thioamide ligand. The product was obtained by sublimation (140 °C, 0.3 Torr). Yield: 0.75 g (82%). M.P.: 86

°C. Sublimation: 105 °C/0.3 Torr. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 4.23 (q, *J* = 7.0 Hz, 4H), 2.84 (h, *J* = 6.7 Hz, 2H), 1.30 (t, *J* = 7.1 Hz, 6H), 1.26 (d, *J* = 6.7 Hz, 12H). ¹³C NMR (101 MHz, C₆D₆) δ (ppm): 154.4, 70.4, 37.1, 21.0, 15.2. Anal. Found (Calcd for C₁₂H₂₄N₂O₂S₂Ge): C, 39.87 (39.48); H, 6.49 (6.63); N, 7.25 (7.67); S, 17.42 (17.57). FT-IR (KBr, cm⁻¹): 2968 (s), 2930 (s), 2869 (m), 1580 (m), 1461 (m), 1381 (m), 1363 (w), 1309 (w), 1199 (w), 1148 (w), 1090 (m), 1052 (s), 996 (s), 950 (m), 921 (s), 846 (m), 701 (w), 678 (w).

Sn(mdpaS)₂ (5). mdpaSH (1.5 g, 10.0 mmol.) was used for *N*-alkoxy thioamide ligand. The white powder product was obtained by sublimation (100 °C, 0.3 Torr). Crystal was colorless. Yield: 1.87 g (91%). M.P.: 90 °C. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 3.62 (s, 6H), 1.42 (s, 18H). ¹³C NMR (126 MHz, C₆D₆) δ (ppm): 171.2, 61.6, 39.8, 30.2. Anal. Found (Calcd for C₁₂H₂₄N₂O₂S₂Sn): C, 34.94 (35.05); H, 5.85 (5.88); N, 6.82 (6.81); S, 15.62 (15.60). HR-MS: [M]⁺ Found (Calcd for C₁₂H₂₄N₂O₂S₂Sn): 412.0302 (412.0301). FT-IR (ATR, cm⁻¹): 2969 (s), 2958 (s), 2940 (m), 2926 (m), 2900 (m), 2863 (m), 2820 (w), 1549 (s), 1480 (m), 1457 (m), 1424 (w), 1391 (m), 1363 (m), 1358 (m), 1249 (w), 1206 (w), 1188 (w), 1149 (w), 1061 (s), 1026 (s), 974 (s), 932 (w), 842 (s), 794 (s), 696 (m), 546 (m), 447 (w).

Sn(edpaS)₂ (6). edpaSH (1.6 g, 10.0 mmol.) was used for *N*-alkoxy thioamide ligand. The white powder product was obtained by sublimation (110 °C, 0.3 Torr). Yield: 2.11 g (96%). M.P.: 61 °C. Sublimation: 110 °C/0.3 Torr. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 4.08 (q, *J* = 7.1 Hz, 2H), 1.44 (s, 9H), 1.12 (t, *J* = 7.0 Hz, 3H). ¹³C NMR (126 MHz, C₆D₆) δ (ppm): 170.4, 71.4, 40.1, 30.3, 15.9. Anal. Found (Calcd for C₁₄H₂₈N₂O₂S₂Sn): C, 38.19 (38.28); H, 6.40 (6.43); N, 6.43 (6.38); S, 14.65 (14.60). HR-MS: [M]⁺ Found (Calcd for C₁₄H₂₈N₂O₂S₂Sn): 440.0640 (440.0614). FT-IR (ATR, cm⁻¹): 2971 (s), 2927 (m), 2898 (m), 2865 (w), 1544 (m), 1480 (m), 1457 (m), 1437 (w), 1385 (m), 1362 (m), 1294 (w), 1248 (w), 1206 (w), 1167 (w), 1092 (m), 1062 (s), 1030 (s), 992 (s), 936 (s), 887 (s), 849 (s), 811 (w), 780 (m), 689 (m), 545 (m), 484 (m).

Sn(bdpaS)₂ (7). bdpaSH (1.9 g, 10.0 mmol.) was used for *N*-alkoxy thioamide ligand. The white powder product was obtained by sublimation (90 °C, 0.3 Torr). Crystal was colorless. Yield: 2.28 g (92%). M.P.: 98 °C. ¹H NMR (500 MHz, C₆D₆) δ (ppm): 1.42 (s, 18H), 1.37 (s, 18H). ¹³C NMR (126 MHz, C₆D₆) δ (ppm): 167.4, 85.7, 40.6, 30.2, 29.3. Anal. Found (Calcd for C₁₈H₃₆N₂O₂S₂Sn): C, 43.40 (43.65); H, 7.36 (7.33); N, 5.63 (5.66); S, 12.65 (12.95). HR-MS: [M]⁺ Found (Calcd for C₁₈H₃₆N₂O₂S₂Sn): 496.1219 (496.1240). FT-IR (ATR, cm⁻¹): 2973 (s), 2927 (m), 2900 (m), 2864 (m), 1559 (m), 1476 (m), 1456 (m), 1388 (m), 1362 (s), 1264 (w), 1242 (w), 1216 (w), 1173 (s), 1049 (s), 1034 (w),

1011 (m), 924 (m), 862 (s), 807 (m), 774 (m), 671 (m), 555 (m).

Sn(empaS)₂ (**8**). empasH (1.5 g, 10.0 mmol.) was used for *N*-alkoxy thioamide ligand. The colorless liquid product was obtained by distillation (90 °C, 0.3 Torr). Yield: 1.81 g (88%). M.P.: 85 °C. ¹H NMR (400 MHz, C₆D₆) δ (ppm): 4.08 (q, *J* = 7.0 Hz, 4H), 3.11 (hept, *J* = 6.9 Hz, 2H), 1.29 (d, *J* = 6.8 Hz, 12H), 1.12 (t, *J* = 7.1 Hz, 6H). ¹³C NMR (101 MHz, C₆D₆) δ (ppm): 168.0, 71.3, 36.1, 22.2, 16.0. Anal. Found (Calcd for C₁₂H₂₄N₂O₂S₂Sn): C, 35.14 (35.05); H, 5.92 (5.88); N, 6.54 (6.81); S, 15.07 (15.60). HR-MS: [M]⁺ Found (Calcd for C₁₂H₂₄N₂O₂S₂Sn): 412.0296 (412.0301). FT-IR (KBr, cm⁻¹): 2967 (m), 2931 (w), 2898 (w), 2869 (w), 1561 (m), 1552 (m), 1464 (m), 1452 (m), 1443 (m), 1381 (s), 1361 (m), 1308 (w), 1294 (w), 1250 (w), 1197 (w), 1167 (w), 1149 (w), 1115 (w), 1089 (w), 1041 (s), 996 (s), 879 (s), 838 (m), 829 (m), 783 (w), 705 (w), 680 (w), 620 (w), 560 (m).

Crystallographic Analysis. Single crystals of **5** and **7** were grown in saturated toluene at room temperature. Reflection data were collected using a Bruker SMART Apex II-CCD area detector diffractometer with graphite-monochromatized Mo- α radiation ($\lambda = 0.71073$ Å). The hemisphere of the reflection data was collected as ω -scan frames at 0.3° per frame and an exposure time of 10 s/frame. The cell parameters were determined and refined using the SMART program.⁵⁹ Data reduction was performed using SAINT software.⁶⁰ The data were corrected for Lorentz and polarization effects. An empirical absorption correction was applied using SADABS software.⁶¹ The structures of the complexes were solved using direct methods and refined by full-matrix least-squares methods using the SHELXTL software package with anisotropic thermal parameters for all non-hydrogen atoms.⁶² Cambridge Crystallographic Data Centre (CCDC) files 2342107 and 2342108 for complexes **5** and **7** contain the supplementary crystallographic data for this paper. The data were obtained free of charge from the CCDC (www.ccdc.cam.ac.uk/data_request/cif).

CONCLUSIONS

A series of homoleptic Ge and Sn complexes **1–8** containing newly created *N*-alkoxy thioamide ligands were synthesized and characterized as potential single-source precursors of group IV metal chalcogenide materials. The crystallized compounds **5** and **7** were found to be monomers with distorted seesaw geometry. Each molecule forms two κ^2 -*O,S*-chelating structures as five-membered rings with the corresponding ligands. The thermal stability and volatility of complexes **1–8** were evaluated by TG analysis. The curves for the series of Ge compounds showed a single-step weight loss, and the Sn complexes showed multistep weight loss. Among these synthesized complexes, **3** and **7** with the bdpaS ligand showed the lowest residual amounts. In summary, all complexes are expected to be useful single precursors for Ge or Sn chalcogenide materials.

ASSOCIATED CONTENT

Supporting Information

The Supporting Information is available free of charge at <https://pubs.acs.org/doi/10.1021/acsomega.4c03019>.

NMR and FT-IR spectra of complexes **1–8** and data collection parameters for complexes **5** and **7** (PDF)

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Notes

The authors declare no competing financial interest.

ACKNOWLEDGMENTS

We gratefully acknowledge the financial support from the Development of Smart Chemical Materials for IoT Devices Project (KS2421-10) through the Korea Research Institute of Chemical Technology.

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